



ELECTRONIC COPY

LG757531969
Report verification at igi.org



January 7, 2026
IGI Report Number **LG757531969**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **13.96 X 9.11 X 6.11 MM**

GRADING RESULTS

Carat Weight **7.60 CARATS**
Color Grade **F**
Clarity Grade **VS 1**

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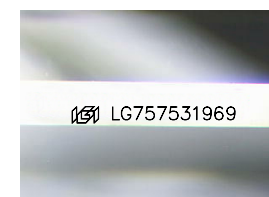
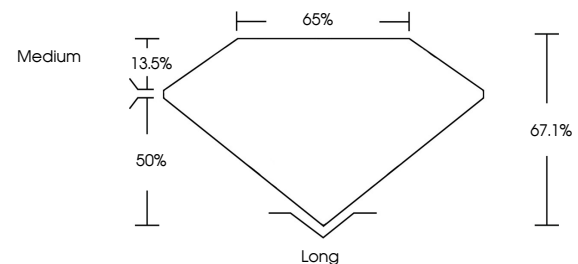
Carat Weight **7.60 CARATS**
Color Grade **F**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG757531969**

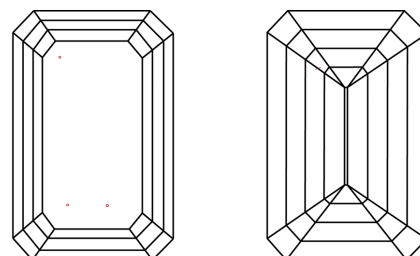
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

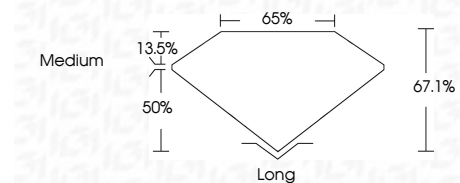
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



January 7, 2026
IGI Report No. **LG757531969**
EMERALD CUT
13.96 X 9.11 X 6.11 MM
Carat Weight **7.60 CARATS**
Color Grade **F**
Clarity Grade **VS 1**
Depth **50%**
Table **13.5%**
Girdle **Medium**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG757531969**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa